Docket No. 740819-548

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re | Patent Application of: |) | ¥ |
|----------------|---|-------------|------------------------|
| Mitsuru TANABE | |) | Group Art Unit: 2817 |
| Seria | l No. 09/838,214 |) | Examiner: Benny T. Lee |
| Filed | : April 20, 2001 |) | |
| For: | MICROSTRIP LINE, METHOD FOR FABRICATING THE SAME, INDUCTOR ELEMENT, AND RF SEMICONDUCTOR DEVICE |))) | |
| | CERTIFICATE OF MAILING | | |

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on 3-27-03.

Commissioner for Patents Washington, D.C. 20231

Sir:

AMENDMENT

dissioner for Patents
Ington, D.C. 20231

In response to the Office Action dated December 3, 2002, please amend file identified application as follows. above-identified application as follows.

IN THE DRAWINGS:

Attached hereto is a request for approval of Drawing Corrections with amended Figures 5C, 12D, 13B, and 14B.

IN THE SPECIFICATION:

Please amend the Specification as follows: